

DEC 23 2003

Sheet 1 of 1

FORM PTO-1449 (SUBSTITUTE)

Attorney Docket No.:

Applic. No.

L&L-I0078

09/939,330

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

Applicant

Alfred Kersch et al.

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT
(37 CFR 1.98(b))

Filing Date

August 24, 2001

Group Art Unit

1762

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
EF	A	5,104,690	04/14/92	Greenwald			
EF	B	5,753,300	05/19/98	Wessels et al.			
	C						
	D						
	E						
	F						
	G						
	H						
	I						

FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
	J	60 026 663	02/09/85	Japan			X
	K						
	L						
	M						
	N						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

EF	O	L.A. Wills et al.: "Deposition of Ferroelectric Bi ₄ Ti ₃ O ₁₂ Thin Films", <i>Extended Abstracts, Fall Meeting, Seattle, Washington, 90/2, 1990, p. 701, Princeton, NJ, XP-000294124</i>
	P	

EXAMINER

DATE CONSIDERED

5/17/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
EF	A	6,191,054 B1	02/20/01	Ohtsuka et al.			
	B						
	C						
	D						
	E						
	F						
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